

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant | : Isamu Kobori et al. | Art Unit | : 2812 |
| Serial No. | : 10/623,581 | Examiner | : Stanetta Isaac |
| Filed | : July 22, 2003 | Conf. No. | : 6534 |
| Title | : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR | | |

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JANUARY 31, 2007

Please amend the above-identified application as follows: